

**SIEMENS**

*Entered*  
*per*  
*ACG*

**PATENT**

**Attorney Docket No. 2003P12715WOUS**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

Inventor:	M. Dankert et al.	)	Group Art Unit:	2855
		)		
Serial No.:	10/589,791	)	Examiner:	O. L. Davis
		)		
Filed:	August 17, 2006	)	Confirmation No.:	3862
		)		
Title	<b>METHOD FOR RECORDING MICROSTRUCTURAL CHANGES IN A COMPONENT</b>			

*PP*  
*12/09/08*

**Commissioner For Patents**  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**Response Under 37 CFR 1.116**

In response to the Final Office Action mailed September 11, 2008, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application to place the claims in condition for allowance or to place the claims in better form for appeal.

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